



15W 2024/10

PATENT
Attorney Docket No. 04329.2409-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Kei YOSHIKAWA et al) Group Art Unit: 2624
)
Application No.: 09/662,219) Examiner: Samir Anwar AHMED
)
Filed: September 14, 2000)
)
For: PATTERN CORRECTING) Confirmation No.: 9438
METHOD OF MASK FOR)
MANUFACTURING A)
SEMICONDUCTOR DEVICE AND)
RECORDING MEDIUM HAVING)
RECORDED ITS PATTERN)
CORRECTING METHOD)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

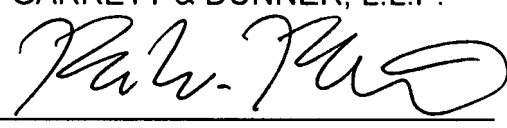
Applicants petition for a two-month extension of time to file a reply to the Office
Action dated April 6, 2007. The required fee of \$450.00 is enclosed.

Please grant any additional extensions of time required to enter the attached
reply and charge any additional required fees to Deposit Account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: September 6, 2007

By: 
Reece Nienstadt
Reg. No. 52,072

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